



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

March 10, 2026

IGI Report Number

LG779646687

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

ROUND BRILLIANT

Measurements

8.84 - 8.87 X 5.38 MM

GRADING RESULTS

Carat Weight

2.57 CARATS

Color Grade

F

Clarity Grade

VS 2

Cut Grade

EXCELLENT

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

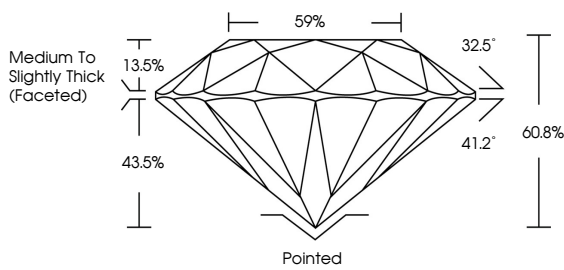
NONE

Inscription(s)

 LG779646687

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)

59%

32.5°

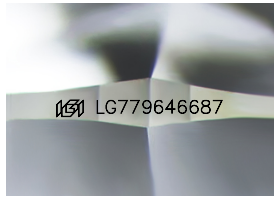
41.2°

60.8%

43.5%

13.5%

Pointed



Sample Image Used

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

FL

IF

VS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Flawless

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included



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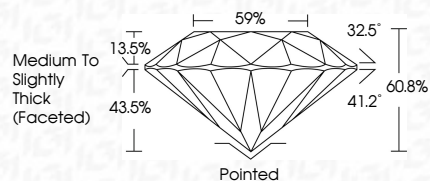
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Depth

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Table

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Culet

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Fluorescence

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